United States Patent Application Publication	20250259921
Kind Code	A1
Publication Date	August 14, 2025
Inventor(s)	YONG; Seokbeom et al.

PACKAGE SUBSTRATE AND SEMICONDUCTOR PACKAGE INCLUDING THE PACKAGE SUBSTRATE

Abstract

A package substrate may include a core layer, a first line layer on a lower surface of the core layer and including multiple layers of first lines, and a second line layer on an upper surface of the core layer and including multiple layers of second lines. The core layer may include a core body and a core via. The core via may penetrate the core body and extend in a vertical direction. A first signal line of the first lines may be connected to a second signal line of the second lines through the core via. The first signal line may be arranged in a form of an inductor in the first line layer.

Inventors: **YONG; Seokbeom (Suwon-si, KR), KIM; Juwon (Suwon-si, KR), PARK; Eunkyeong (Suwon-si, KR), SONG; Sangsub (Suwon-si, KR), AHN; Sungoh (Suwon-si, KR), YU; Seulgi (Suwon-si, KR)**

Applicant: **Samsung Electronics Co., Ltd.** (Suwon-si, KR)

Family ID: **1000008154294**

Assignee: **Samsung Electronics Co., Ltd. (Suwon-si, KR)**

Appl. No.: **18/822728**

Filed: **September 03, 2024**

Foreign Application Priority Data

KR	10-2024-0020902	Feb. 14, 2024

Publication Classification

Int. Cl.: **H01L23/498** (20060101)

U.S. Cl.:

Background/Summary

CROSS-REFERENCE TO RELATED APPLICATION

[0001] This application is based on and claims priority under 35 U.S.C. § 119 to Korean Patent Application No. 10-2024-0020902, filed on Feb. 14, 2024, in the Korean Intellectual Property Office, the disclosure of which is incorporated by reference herein in its entirety.

BACKGROUND

[0002] Inventive concepts relate to a semiconductor package, and more particularly, to a package substrate and a semiconductor package including the package substrate.

[0003] According to the rapid development of the electronics industry and user demands, electronic devices have become smaller and lighter. As electronic devices have become smaller and lighter, semiconductor packages used in electronic devices also have become smaller and lighter, and the semiconductor packages also may be required to have high reliability together with high performance and large capacity. For example, regarding the reliability of the semiconductor packages, as the semiconductor packages have become smaller and have increased in operating speeds, problems with signal integrity (SI) characteristics may occur due to noise. Accordingly, research and development on package structures capable of addressing SI characteristics problems have been continuously conducted.

SUMMARY

[0004] Inventive concepts provide a package substrate with improved signal integrity (SI) characteristics and physical reliability of a substrate, and a semiconductor package including the package substrate.

[0005] In addition, aspects of inventive concepts are not limited to those mentioned above, and other aspects may be clearly understood by those skilled in the art from the description below.

[0006] According to an embodiment of inventive concepts, a package substrate may include a core layer; a first line layer on a lower surface of the core layer and including multiple layers of first lines; and a second line layer on an upper surface of the core layer and including multiple layers of second lines. The core layer may include a core body and a core via. The core via may penetrate the core body and may extend in a vertical direction. A first signal line of the first lines may be connected to a second signal line of the second lines through the core via, and the first signal line may be arranged in a form of an inductor in the first line layer.

[0007] According to an embodiment of inventive concepts, a package substrate may include a body layer having an upper surface and a lower surface; and multiple layers of lines in the body layer. The lines may include a signal line configured to transmit a signal. The signal line may include a horizontal line and a vertical via. The horizontal line may extend in the body layer in a horizontal direction parallel to the upper surface of the body layer. The vertical via may be configured to connect adjacent horizontal lines in a vertical direction to each other in the body layer. The vertical direction may be perpendicular to the horizontal direction, and the horizontal line and the vertical via may configure an inductor in the body layer.

[0008] According to an embodiment of inventive concepts, a semiconductor package may include a package substrate; at least one semiconductor device mounted on the package substrate; and a sealant configured to seal the at least one semiconductor device on the package substrate. The package substrate may include a body layer having an upper surface and a lower surface and multiple layers of lines in the body layer. The lines may include a signal line configured to transmit a signal. The signal line may include a horizontal line and a vertical via. The horizontal line may extend in the body layer in a horizontal direction parallel to the upper surface of the body layer, and

the vertical via may be configured to connect adjacent horizontal lines in a vertical direction to each other in the body layer. The horizontal line and the vertical via may configure an inductor in the body layer.

Description

BRIEF DESCRIPTION OF THE DRAWINGS

[0009] Embodiments of inventive concepts will be more clearly understood from the following detailed description taken in conjunction with the accompanying drawings in which:

[0010] FIGS. **1**A and **1**B are cross-sectional views of a package substrate according to an embodiment;

[0011] FIGS. **2**A to **2**C are three-dimensional perspective views and a cross-sectional view, each illustrating a first signal line of a first line layer in the package substrate of FIG. **1**B;

[0012] FIGS. **3**A and **3**B are conceptual diagrams showing in a plan view a structure of an inductor formed by the first signal line in the package substrate of FIG. **1**B;

[0013] FIGS. **4**A and **4**B are conceptual diagrams showing in a plan view the position of a first vertical via of the first signal line in the package substrate of FIG. **1**B;

[0014] FIGS. **5**A to **5**C are cross-sectional views of package substrates according to comparative examples and a cross-sectional view of the package substrate of FIG. **1**B;

[0015] FIGS. **6**A and **6**B are cross-sectional views for describing the physical reliability of the package substrate of a comparative example and the package substrate of FIG. **1**B;

[0016] FIGS. **7**A and **7**B are a time domain reflectometry (TDR) graph and an insertion loss graph of a package substrate of a first comparative example and the package substrate of FIG. **1**B;

[0017] FIGS. **8**A and **8**B are photos of the eye diagrams of the package substrate of the first comparative example and the package substrate of FIG. **1**B;

[0018] FIG. **9** is a cross-sectional view of a package substrate according to an embodiment;

[0019] FIGS. **10**A and **10**B are a TDR graph and an insertion loss graph of the package substrate of the first comparative example and the package substrate of FIG. **9**;

[0020] FIGS. **11**A to **12** are cross-sectional views of semiconductor packages according to embodiments;

[0021] FIGS. **13**A and **13**B are a perspective view and a cross-sectional view of a semiconductor device according to an embodiment; and

[0022] FIG. **14** is a cross-sectional view of a semiconductor device according to an embodiment.

DETAILED DESCRIPTION OF THE EMBODIMENTS

[0023] The notion that elements are “substantially the same” may indicate that the element may be completely the same and may also indicate that the elements may be determined to be the same in consideration of errors or deviations occurring during a process.

[0024] Hereinafter, inventive concepts will now be described more fully with reference to the accompanying drawings, in which embodiments of inventive concepts are shown. Like reference numerals in the drawings denote like elements, and thus their description will be omitted.

[0025] FIGS. **1**A and **1**B are cross-sectional views of a package substrate according to an embodiment, and FIG. **1**B is an enlarged cross-sectional view of a portion A of FIG. **1**A. FIGS. **2**A to **2**C are three-dimensional perspective views and a cross-sectional view, each illustrating a first signal line of a first line layer in the package substrate of FIG. **1**B, FIG. **2**B is an enlarged perspective view of a portion B of FIG. **2**A, and FIG. **2**C is a cross-sectional view taken along a line I-I′ of FIG. **2**B.

[0026] Referring to FIGS. **1**A to **2**C, a package substrate **100** according to an embodiment may include a first line layer **110**, a core layer **120**, a second line layer **130**, and a protective layer **140**. The package substrate **100** may be, for example, a printed circuit board (PCB). However, the

package substrate **100** is not limited to the PCB.
[0027] The core layer **120** may include a core body **121** and a core via **123**. The core body **121** may include, for example, a glass fiber, such as FR4, and a resin. However, the material of the core body **121** is not limited thereto. For example, the core body **121** may include a bismaleimide-triazine (BT) resin, a polycarbonate (PC), build-up films such as an Ajinomoto build-up film, or other laminate resins. In addition, the core body **121** may also include glass, which is an inorganic material. The core body **121** may have a flat plate shape and may have a relatively thin thickness. For example, the thickness of the core body **121** may be about 40 μm to about 200 μm. However, the thickness of the core body **121** is not limited to the above range.
[0028] The core via **123** may penetrate the core body **121** and extend in a vertical direction, that is, a z direction. The core via **123** may be arranged between a first core pad CP**1** and a second core pad CP**2**, wherein the first core pad CP**1** is on the lower surface of the core via **123**, and the second core pad CP**2** is on the upper surface of the core via **123**. For reference, the first core pad CP**1** may be included as a portion of a first line **115**, and the second core pad CP**2** may be included as a portion of a second line **135**. However, in some embodiments, the first core pad CP**1** and the second core pad CP**2** may also be treated as separate components from the first line **115** and the second line **135**.
[0029] Each of the core via **123**, the first core pad CP**1**, and the second core pad CP**2** may include metal. For example, each of the core via **123**, the first core pad CP**1**, and the second core pad CP**2** may include copper (Cu), tungsten (W), aluminum (Al), nickel (Ni), cobalt (Co), titanium (Ti), titanium nitride (TiN), or the like. In the package substrate **100** of the embodiment, each of the core via **123**, the first core pad CP**1**, and the second core pad CP**2** may include Cu. However, the material of each of the core via **123**, the first core pad CP**1**, and the second core pad CP**2** is not limited to Cu.
[0030] The first line layer **110** may be arranged on the lower portion of the core layer **120**. The first line layer **110** may include a first body **111** and the first line **115**. The first body **111** may include an insulating dielectric material. For example, the first body **111** may include silicon, ceramic, an organic material, glass, an epoxy resin, or the like. In the package substrate **100** of the embodiment, the first body **111** may include, for example, prepreg (PPG). However, the material of the first body **111** is not limited to PPG. The first body **111** may have a multi-layered structure depending on the number of layers of the first line **115**. For example, the first body **111** may have a structure in which a number of PPGs, which corresponds to the number of layers of the first line **115**, are stacked. However, in FIG. **1**B and the below cross-sectional views, for convenience of explanation, the first body **111** is shown as a single layer.
[0031] The first line **115** may be arranged within the first body **111** in multiple layers. For example, the first line **115** may be arranged within the first body **111** in three to ten layers. However, the number of layers of the first line **115** is not limited to the above range. The thickness of the first line layer **110** or the first body **111** may be different depending on the number of layers of the first line **115**. In other words, the thickness of the first line layer **110** or the first body **111** may increase as the number of layers of the first line **115** increases. For example, the thickness of the first line layer **110** may be about 50 μm to about 500 μm. In a particular example, when the first line **115** is arranged within the first body **111** in four layers, the thickness of the first line layer **110** may be 250 μm. However, the thickness of the first line layer **110** and the number of layers of the first line **115** are not limited to the above ranges.
[0032] The first line **115** may include a horizontal line **117** and a vertical via **119** within the first body **111**, wherein the horizontal line **117** extends in a horizontal direction, for example, an x direction and/or a y direction, and the vertical via **119** is connected to adjacent horizontal lines in the vertical direction, that is, the z direction. Each of the horizontal line **117** and the vertical via **119** may include metal. For example, each of the horizontal line **117** and the vertical via **119** may include Cu, W, Al, Ni, Co, Ti, TiN, or the like. In the package substrate **100** of the embodiment,

each of the horizontal line **117** and the vertical via **119** may include, for example, Cu. However, the material of each of the horizontal line **117** and the vertical via **119** is not limited to Cu.
[0033] The first line **115** may include a lower substrate pad SPd arranged on the lowest end of the first body **111**. As shown in FIG. **1**B, an external connection terminal **150** may be arranged on the lower surface of the lower substrate pad SPd. In some embodiments, the lower substrate pad SPd may be treated as a different component from the first line **115**. The external connection terminal **150** is a separate component from the package substrate **100**, but in some embodiments, the external connection terminal **150** may also be treated as a portion of the package substrate **100**.
[0034] In the package substrate **100** of the embodiment, the first line **115** may be largely divided into a first signal line **115**S and a first ground/power line **115**G/P. The first signal line **115**S may transmit a signal, and the first ground/power line **115**G/P may transmit ground or power. In more particular, the first signal line **115**S may include a first horizontal line **117**S of the horizontal line **117** and a first vertical via **119**S of the vertical via **119**. In addition, the first ground/power line **115**G/P may include a first horizontal line **117**G/P of the horizontal line **117** and a first vertical via **119**G/P of the vertical via **119**.
[0035] For reference, in terms of voice prevention, a ground line and a power line may be arranged within a package substrate in a certain area. Accordingly, the ground line may be referred to as a ground plane, and the power line may be referred to as a power plane. Therefore, in the package substrate **100** of the embodiment, the first ground/power line **115**G/P may also be referred to as a first ground/power plane.
[0036] The second line layer **130** may be arranged on the upper portion of the core layer **120**. The second line layer **130** may include a second body **131** and the second line **135**. The second line layer **130** may be substantially the same as the first line layer **110**. Accordingly, descriptions of the materials of the second body **131** and the second line **135** are omitted. The number of layers of the second line **135** may be the same as or different from the number of layers of the first line **115**.
[0037] The second line **135** may include a horizontal line **137** and a vertical via **139** within the second body **131**, wherein the horizontal line **137** extends in a horizontal direction, for example, the x direction and/or the y direction, and the vertical via **139** is connected to adjacent horizontal lines in the vertical direction, that is, the z direction. The materials of the horizontal line **137** and the vertical via **139** are the same as those mentioned for the horizontal line **117** and the vertical via **119**. Although not illustrated in the drawings, the second line **135** may include an upper substrate pad arranged on the uppermost end of the second body **131**. A connection terminal of a semiconductor chip or semiconductor package stacked on the package substrate **100** may be arranged on the upper surface of the upper substrate pad. In some embodiments, the upper substrate pad may also be treated as a different component from the second line **135**.
[0038] In the package substrate **100** of the embodiment, the second line **135** may be largely divided into a second signal line **135**S and a second ground/power line **135**G/P. The second signal line **135**S may transmit a signal, and the second ground/power line **135**G/P may transmit ground or power. In more particular, the second signal line **135**S may include a second horizontal line **137**S of the horizontal line **137** and a second vertical via **139**S of the vertical via **139**. As indicated by an arrow in FIG. **1**B, the second horizontal line **137**S may include a relatively long portion extending in the horizontal direction. As such, the long extending portion of the second horizontal line **137**S is referred to as a trace line or a routing line. The second ground/power line **135**G/P may include a second horizontal line **137**G/P of the horizontal line **137** and a second vertical via **139**G/P of the vertical via **139**. In the package substrate **100** of the embodiment, the second ground/power line **135**G/P may also be referred to as a second ground/power plane.
[0039] As can be seen through FIG. **1**B, the first signal line **115**S may be connected to the second signal line **135**S through a corresponding core via **123**. In addition, the first signal line **115**S may be connected to a corresponding external connection terminal **150** through the lower substrate pad SPd. The first ground/power line **115**G/P may be connected to the second ground/power line

135G/P through a corresponding core via **123** and may also be connected to a corresponding external connection terminal **150** through the lower substrate pad SPd. In FIG. **1**B, the first signal line **115**S in the first line layer **110**, the second signal line **135**S in the second line layer **130**, and the core via **123** of the core layer **120** corresponding to the first signal line **115**S and the second signal line **135**S are indicated with the same hatching. In addition, the first ground/power line **115**G/P in the first line layer **110**, the second ground/power line **135**G/P in the second line layer **130**, and the core via **123** in the core layer **120** corresponding to the first ground/power line **115**G/P and the second ground/power line **135**G/P are indicated with the same hatching and are distinguished from the first signal line **115**S, the second signal line **135**S, and the core via **123** corresponding to the first signal line **115**S and the second signal line **135**S.

[0040] The protective layer **140** may be a layer that protects the first line layer **110**, the core layer **120**, and the second line layer **130** from external physical and chemical damage. The protective layer **140** may include, for example, a solder resistor (SR). The protective layer **140** may include an upper protective layer **140***u* on the second line layer **130** and a lower protective layer **140***d* on the first line layer **110**. Each of the upper protective layer **140***u* and the lower protective layer **140***d* may have a relatively thin thickness, for example, about 20 μm. However, the thickness of each of the upper protective layer **140***u* and the lower protective layer **140***d* is not limited to 20 μm.

[0041] In the package substrate **100** of the embodiment, the first signal line **115**S of the first line layer **110** may form an inductor within the first body **111**. In more particular, the first signal line **115**S may include the first horizontal line **117**S and the first vertical via **119**S. In a plan view, the first vertical via **119**S may be distinguished into a first vertical via group **119**Sg**1** arranged at a first position, a second vertical via group **119**Sg**2** arranged at a second position spaced apart from the first position, and an upper vertical via **119**Su arranged at a third position spaced apart from the first position and the second position. In some embodiments, the upper vertical via **119**Su may also be arranged at the first position or the second position to be included in the first vertical via group **119**Sg**1** or the second vertical via group **119**Sg**2**.

[0042] Based on a line connecting the first vertical via group **119**Sg**1** and the second vertical via group **119**Sg**2**, the first horizontal line **117**S may be distinguished into a first horizontal line group **117**Sg**1** arranged by any one side and a second horizontal line group **117**Sg**2** arranged on the other side. The first horizontal line **117**S may include a via pad portion **117**Sp connected to the first vertical via **119**S and a line portion **117**Sw extending in a horizontal direction from the via pad portion **117**Sp. The first horizontal line **117**S and the first vertical via **119**S arranged in the above structure may configure an inductor in a structure rotating clockwise or counterclockwise while the first horizontal line **117**S is connected to a first horizontal line **117**S of another layer through the first vertical via **119**S.

[0043] In particular, in FIG. **2**B, the first vertical via **119**S at the lowermost end of the first vertical via group **119**Sg**1** may be arranged on the lower substrate pad SPd, and the first horizontal line **117**S at the lowermost end of the first horizontal line group **117**Sg**1** may connect the first vertical via **119**S at the lowermost end of the first vertical via group **119**Sg**1** to the first vertical via **119**S at the lowermost end of the second vertical via group **119**Sg**2** while extending clockwise. In addition, the first horizontal line **117**S at the lowermost end of the second horizontal line group **117**Sg**2** may connect the first vertical via **119**S at the lowermost end of the second vertical via group **119**Sg**2** to the first vertical via **119**S at the second level of the first vertical via group **119**Sg**1** while extending clockwise. With such a connection relationship, the first horizontal line **117**S and the first vertical via **119**S may extend in a z direction in the form of a spring that rotates clockwise. The first vertical via **119**S at the uppermost end of the first vertical via group **119**Sg**1** may be connected to the first horizontal line **117**S at the uppermost end of the first horizontal line group **117**Sg**1**, and the first horizontal line **117**S at the uppermost end may extend clockwise to be connected to the upper vertical via **119**Su. The upper vertical via **119**Su may be connected to the first core pad CP**1**, as shown in FIG. **2**A.

[0044] In FIG. **2**B, an example in which the first horizontal line **117**S has a five-layered structure is shown. The number of layers of the first horizontal line **117**S may be generalized to n layers and described as follows. Here, n is an integer of 3 or more. When n is an even number, the first vertical via group **119**Sg**1** may include a zeroth via on the lower substrate pad SPd of the package substrate **100**, a second via on a second layer, . . . , and an n−2-th via on an n−2-th layer. The second vertical via group **119**Sg**2** may include a first via on a first layer, a third via on a third layer, . . . , and an n−1-th via on an n−1-th layer. In addition, the first horizontal line group **117**Sg**1** may include a first line, a third line, . . . , and an n−1-th line, and the second horizontal line group **117**Sg**2** may include a second line, a fourth line, . . . , and an n-th line.

[0045] When n is an odd number, the first vertical via group **119**Sg**1** may include a zeroth via on the lower substrate pad SPd of the package substrate **100**, a second via on a second layer, . . . , and an n−1-th via on an n−1-th layer, and the second vertical via group **119**Sg**2** may include a first via on a first layer, a third via on a third layer, . . . , and an n−2-th via on an n−2-th layer. In addition, the first horizontal line group **117**Sg**1** may include a first line, a third line, . . . , an n-th line, and the second horizontal line group **117**Sg**2** may include a second line, a fourth line, . . . , an n−1-th line.

[0046] In the package substrate **100** of the embodiment, as the first signal line **115**S is arranged within the first body **111** of the first line layer **110** to configure an inductor, an impedance seen at the lower substrate pad SPd may increase, and thus the variability or discontinuity of the impedance may be improved. Due to the improvement in impedance discontinuity, the insertion loss decreases, and an eye-opening value increases, and thus signal integrity (SI) characteristics of the package substrate **100** and a semiconductor package including the package substrate **100** may be improved. In addition, due to the improvement in impedance discontinuity, there is no need to generate a dielectric void (refer to DV of FIG. **5**B) within the first body **111**, and thus the physical reliability of the package substrate **100** may be improved. The improvement in impedance discontinuity and the improvement in physical reliability of a package substrate are described in more detail in the descriptions of FIGS. **4**A to **8**B.

[0047] FIGS. **3**A and **3**B are conceptual diagrams showing the structure of an inductor formed by the first signal line in the package substrate of FIG. **1**B in a plan view. Descriptions already given with reference to FIGS. **1**A to **2**C are simply described or omitted.

[0048] Referring to FIG. **3**A, in the package substrate **100** of the embodiment, the first signal line **115**S may configure an inductor within the first body **111** of the first line layer **110**. In addition, the inductor configured by the first signal line **115**S may have a spring form extending in a vertical direction, that is, a z direction, while rotating clockwise or counterclockwise. The inductor configured by the first signal line **115**S may have a rectangular form in an x-y plane perpendicular to the z direction, as shown in FIG. **3**A. For example, the first horizontal line **117**S may configure four sides of a square. For reference, the arrow in FIG. **3**A may mean that the inductor rotates clockwise.

[0049] Referring to FIG. **3**B, in the package substrate **100** of the embodiment, an inductor configured by a first signal line **115**S′ may have a spring form extending in a vertical direction, that is, a z direction, while rotating clockwise or counterclockwise. In addition, the inductor configured by the first signal line **115**S′ may have a circular form in an x-y plane perpendicular to the z direction, as shown in FIG. **3**B. For example, a first horizontal line **117**S′ may configure the circumference of a circle. The arrow in FIG. **3**B may mean that the inductor rotates clockwise.

[0050] The case where the planar form of an inductor configured by a first signal line is a square form or a circular form is described. However, the planar form of the inductor configured by the first signal line is not limited thereto. For example, the planar form of the inductor configured by the first signal line may also be an elliptical form or a polygonal form other than a square form.

[0051] FIGS. **4**A and **4**B are conceptual diagrams showing the position of a first vertical via of the first signal line in the package substrate of FIG. **1**B in a plan view. Descriptions already given with reference to FIGS. **1**A to **3**B are simply described or omitted.

[0052] Referring to FIG. **4**A, in the package substrate **100** of the embodiment, the first vertical via **119**S of the first signal line **115**S may include, on an x-y plane perpendicular to a z direction, the first vertical via group **119**Sg**1** arranged at a first position, the second vertical via group **119**Sg**2** arranged at a second position spaced apart from the first position, and the upper vertical via **119**Su arranged at a third position spaced apart from the first position and the second position.
[0053] FIG. **4**A shows the planar position of the first vertical via **119**S as seen from the top, the large circle may correspond to the lower substrate pad SPd, and small circles may correspond to the first vertical via **119**S. The outer portion of the lower substrate pad SPd may correspond to the first horizontal line **117**G/P of the first ground/power line **115**G/P. In addition, a space between the first horizontal line **117**G/P and the lower substrate pad SPd may be filled with a dielectric material of the first body **111**.
[0054] Referring to FIG. **4**B, in the package substrate **100** of the embodiment, a first vertical via **119**S′ of a first signal line **115**S″ may include, on an x-y plane perpendicular to a z direction, the first vertical via group **119**Sg**1** arranged at a first position and a second vertical via group **119**Sg**2** arranged at a second position spaced apart from the first position. In addition, the upper vertical via **119**Su may be arranged at the second position to be included in the second vertical via group **119**Sg**2**. According to an embodiment, the upper vertical via **119**Su may also be arranged at the first position to be included in the first vertical via group **119**Sg**1**.
[0055] FIGS. **5**A to **5**C are cross-sectional views of package substrates according to comparative examples and a cross-sectional view of the package substrate of FIG. **1**B, and FIGS. **6**A and **6**B are cross-sectional views for describing the physical reliability of the package substrate of a comparative example and the package substrate of FIG. **1**B.
[0056] Referring to FIG. **5**A, in the case of a package substrate Com.1 of a first comparative example, a signal line S on a ball pad BP may not include separate horizontal lines. However, as shown in FIG. **5**A, the signal line S may also include about one horizontal line Sw at a mid-height position. Accordingly, the signal line S may be connected from the ball pad BP to a core via CV through vertical vias Sv without horizontal lines. For reference, a slightly wider portion between the vertical vias Sv in a z direction may correspond to a via pad.
[0057] A ground/power line G/P may be arranged adjacent to the signal line S. The ground/power line G/P may include a horizontal line G/Pw and a vertical via G/Pv. In FIG. **5**A, B may mean a solder ball and may correspond to an external connection terminal of the package substrate Com. 1 of a first comparative example. In addition, the ball pad BP on which the solder ball B is arranged may correspond to a lower substrate pad of the package substrate Com.1 of a first comparative example.
[0058] Referring to FIG. **5**B, in the case of a package substrate Com.2 of a second comparative example, the structure of the signal line S may be substantially the same as the structure of the signal line S of the package substrate Com.1 of the first comparative example. However, in the case of the package substrate Com.2 of the second comparative example, the ground/power line G/P on the upper portion of the ball pad BP may not be arranged directly adjacent to the signal line S, and a dielectric void DV may be formed between the signal line S and the ground/power line G/P. Here, the dielectric void DV may mean a portion filled only with a dielectric material without a conductive layer such as metal. In the package substrate Com.2 of the second comparative example, the reason that the dielectric void DV is formed between the signal line S and the ground/power line G/P on the upper portion of the ball pad BP may be to reduce the impedance variability and discontinuity.
[0059] To describe in more detail regarding impedance discontinuity, because the speed of IP (Internet Protocal)) was not fast in the related art, reducing the crosstalk/noise of a signal being ball-out, that is, a signal being output, was more important, and impedance discontinuity could be ignored to some extent. However, recently, as the speed of IP has increased, impedance discontinuity has become important. The impedance discontinuity may occur frequently in areas

where ball pads, vertical vias, bump pads (or upper substrate pads), or the like are arranged, except for areas where trace lines are arranged. In particular, because a ball pad usually has a much larger area than a vertical via or a bump pad, large impedance discontinuity may occur in the area of the ball pad. The impedance discontinuity may be mainly caused by a parasitic capacitor between the signal line S and the ground/power line G/P, especially a parasitic capacitor between the ball pad BP and the ground/power line G/P, as shown in FIG. **5**A. For example, in FIG. **5**A, a thickly marked capacitor may have a capacitance tens to hundreds of times greater than a thinly marked capacitor.

[0060] Accordingly, to reduce impedance discontinuity, a structure in which the ground/power line G/P positioned on the upper portion of the ball pad BP is removed is used to reduce a capacitance component visible in the ball pad BP, and the package substrate Com.2 of the second comparative example of FIG. **5**B may correspond to such a structure. For reference, a package substrate in a structure in which the ground/power line G/P positioned on the upper portion of the ball pad BP is removed is called a package substrate in an anti-pad structure. As can be seen through FIG. **5**B, in case of a package substrate in an anti-pad structure, the dielectric void DV may be formed on the upper portion of the ball pad BP, and accordingly, the ball pad BP may not overlap the ground/power line G/P in a z direction. Such a package substrate in the anti-pad structure may be beneficial in terms of improvement on impedance discontinuity.

[0061] However, as the dielectric void DV exists on the upper portion of the ball pad BP, the package substrate may be vulnerable to physical reliability such as cracks. For example, as can be seen through FIG. **6**A, when a crack CK occurs in a package substrate as indicated by the thick arrow in a z direction, the crack CK easily progresses upward through the dielectric void DV, significant physical damage may occur in the package substrate, and thus the physical reliability of the package substrate may be reduced. In addition, damage to the package substrate may lead to an open or short circuit, thereby reducing the electrical reliability of the package substrate. Furthermore, the size of a ball pad increases in a large-area package substrate, and accordingly, the size of the dielectric void DV also increases, thereby further increasing the problem of physical reliability of the package substrate.

[0062] Referring to FIG. **5**C, in the case of the package substrate **100** of the embodiment, an inductor In. may be formed within the first body **111** of the first line layer **110** by the first signal line **115**S. Accordingly, all of the problems of the package substrates Com.1 and Com.2 of the above comparative examples may be solved. In particular, in the case of the package substrate **100** of the embodiment, because the dielectric void DV is not formed, the problem in physical reliability of the package substrate Com.2 of the second comparative example may be solved. For example, as can be seen through FIG. **6**B, even when the crack CK occurs in a package substrate as indicated by the thick arrow in a z direction, because the first ground/power line **115**G/P exists on the upper portion of a lower substrate pad SPb without the dielectric void DV, the crack CK may be blocked by the first ground/power line **115**G/P and may not proceed upward. That is, at least a portion of the lower substrate pad SPb may overlap the first ground/power line **115**G/P in the z direction. Accordingly, physical damage to the package substrate **100** may be reduced, and the physical reliability of the package substrate **100** may be improved.

[0063] In addition, as the inductance In. by an inductor of the first signal line **115**S is added, an impedance seen at a ball pad, that is, the lower substrate pad SPb, may increase, thereby improving impedance discontinuity. Accordingly, the problem in impedance discontinuity of the package substrate Com.1 of the first comparative example may be solved.

[0064] For reference, in general, a total impedance Z may be inversely proportional to the square root of a capacitance C and proportional to the square root of an inductance L, as shown in Equation (1) below.

$Z \propto (L/C)$.sup.1/2 Equation (1)

[0065] Accordingly, when a capacitance increases due to a parasitic capacitor Cap., the total impedance Z decreases. To reduce such a decrease of total impedance Z, in the package substrate Com.1 of the first comparative example, a parasitic capacitor is removed by generating the dielectric void DV, and the total impedance Z is increased to improve impedance discontinuity. Conversely, in the package substrate **100** of the embodiment, as an inductor In. is added through the first signal line **115**S, the total impedance Z is increased to improve impedance discontinuity.
[0066] FIGS. **7**A and **7**B are a time domain reflectometry (TDR) graph and an insertion loss graph of a package substrate of a first comparative example and the package substrate of FIG. **1**B, wherein the dotted line represents the package substrate Com. 1 of the first comparative example, and the solid line represents the package substrate **100** of FIG. **1**B. In FIG. **7**A, the x axis represents time and the unit thereof is nano-seconds (ns), and the y axis represents impedance and the unit thereof is ohm (**22**). In FIG. **7**B, the x axis represents frequency and the unit thereof is gigahertz (GHz), and the y axis represents insertion loss and the unit thereof is dB.
[0067] Referring to FIG. **7**A, Ball, Core, Trace, and Bump shown in the upper portion of the graph may respectively indicate the lower substrate pad SPb, the core via **123**, the trace line of the second line **135**, and a bump pad (or an upper substrate pad). The graph of FIG. **7**A shows the impedance over time or the impedance at a corresponding position when a signal is transmitted from the external connection terminal **150**.
[0068] As can be seen through the graph of FIG. **7**A, the impedance is significantly lowered in the portion of the lower substrate pad SPb. Such a phenomenon in which impedance varies depending on a corresponding position of a package substrate is called impedance variability or discontinuity. In addition, in the case of the package substrate Com.1 of the first comparative example, the impedance at the lower substrate pad SPb drops to 17Ω, which is less than 20Ω, and in the case of the package substrate **100** of the embodiment, the impedance at the lower substrate pad SPb is lowered to only about 26Ω, thereby improving impedance discontinuity. Such an improvement in impedance discontinuity may improve signal integrity (SI) characteristics, as can be seen in FIGS. **8**A and **8**B.
[0069] Referring to FIG. **7**B, in the case of insertion loss, it may be confirmed that the package substrate **100** of the embodiment is improved over the package substrate Com.1 of the first comparative example. In particular, in a first frequency (4 GHZ), the insertion loss of the package substrate Com.1 of the first comparative example is −1.425 dB, and the insertion loss of the package substrate **100** of the embodiment is −1.103 dB, which can be confirmed that the insertion loss of the package substrate **100** of the embodiment has improved by about 22%. In addition, in a second frequency (8 GHZ), the insertion loss of the package substrate Com.1 of the first comparative example is −1.864 dB, and the insertion loss of the package substrate **100** of the embodiment is −1.356 dB, which can be confirmed that the insertion loss of the package substrate **100** of the embodiment has improved by about 27%.
[0070] FIGS. **8**A and **8**B are photos of the eye diagrams of the package substrate of the first comparative example and the package substrate of FIG. **1**B. In FIGS. **8**A and **8**B, the x axis represents time and the unit thereof is picosecond (ps), and the y axis represents a signal voltage and the unit thereof is arbitrary.
[0071] Referring to FIGS. **8**A and **8**B, in the eye diagrams, the width of a portion indicated as a rectangle represents an eye-opening, and the width of an intersection portion represents an eye jitter or a timing jitter. As can be seen through FIGS. **8**A and **8**B, the eye-opening of the package substrate **100** of the embodiment is larger and the eye jitter thereof is smaller compared to the package substrate Com.1 of the first comparative example. In particular, when calculating with a 6.4 Gbps signal, a signal period may be 156.25 ps, the eye-opening value of the package substrate **100** of the embodiment may be calculated to be about 100/156.25=64%, and the eye-opening value of the package substrate Com.1 of the first comparative example may be calculated to be about 81.7/156.25=52%. Accordingly, it may be confirmed that the eye-opening characteristics of the

package substrate **100** of the embodiment have improved by about 12% compared to the package substrate Com.1 of the first comparative example.

[0072] FIG. **9** is a cross-sectional view of a package substrate according to an embodiment. Descriptions already given with reference to FIGS. **1**A to **6**B are briefly made or omitted.

[0073] Referring to FIG. **9**, a package substrate **100***a* according to an embodiment may be different from the package substrate **100** of FIG. **1**B in the structure of a first line layer **110***a*. In particular, the package substrate **100***a* of the embodiment may include the first line layer **110***a*, a core layer **120**, a second line layer **130**, and a protective layer **140**. The package substrate **100***a* may be, for example, a PCB. However, the package substrate **100***a* is not limited to a PCB. The core layer **120**, the second line layer **130**, and the protective layer **140** are as described in the description of the package substrate **100** of FIG. **1**B.

[0074] The first line layer **110***a* may be arranged on the lower portion of the core layer **120**. The first line layer **110***a* may include a first body **111** and a first line **115***a*. The first body **111** is as described in the description of the package substrate **100** of FIG. **1**B.

[0075] The first line **115***a* may be arranged within the first body **111** in multiple layers. For example, the first line **115***a* may be arranged within the first body **111** in three layers to ten layers. However, the number of layers of the first line **115***a* is not limited to the above range. In the package substrate **100***a* of the embodiment, the first line **115***a* may be divided into a first signal line **115**Sa and a first ground/power line **115**G/P.

[0076] The first signal line **115**Sa may include a stacked via SV. Here, the stacked via SV may refer to a structure in which vertical vias are stacked in the vertical direction with via pads therebetween. For example, the stacked via SV may include a first vertical via **119**S and a first via pad **118**S. The via pad **118**S may be included in the first signal line **115**Sa. In addition, as shown in FIG. **9**, a first horizontal line **117**S and the first vertical via **119**S, which configure an inductor In., may be arranged on the upper portion of the stacked via SV.

[0077] In the package substrate **110***a* of the embodiment, first horizontal lines **117**G/P of the first ground/power line **115**G/P may surround the via pads **118**S in correspondence to the stacked via SV. For example, the stacked via SV may include first via pads **118**S of the first and second layers on the upper portion of a lower substrate pad SPd, and the first horizontal lines **117**G/P may adjacently surround the first via pads **118**S of the first and second layers. The structures of the inductor In. on the upper portion of the stacked via SV and the first horizontal lines **117**G/P surrounding the inductor In. may be substantially the same as the structures of the inductor In. and the first horizontal lines **117**G/P surrounding the inductor In. of the package substrate **100** of FIG. **1**B.

[0078] In the package substrate **100***a* of the embodiment, due to the structures of the stacked via SV of the first signal line **115**Sa and the ground/power line **115**G/P corresponding to the stacked via SV, a crack prevention function may be strengthened by the first horizontal lines **117**G/P surrounding the first via pads **118**S, as described above with reference to FIG. **6**B. In addition, because the inductor In. is maintained on the upper portion of the stacked via SV, the impedance may increase and impedance discontinuity may be improved.

[0079] The structures of the stacked via SV of the first signal line **115**Sa and the ground/power line **115**G/P are not limited to the structures of the two via pads **118**S and the first horizontal lines **117**G/P surrounding the via pads **118**S. For example, the structures of the stacked via SV of the first signal line **115**Sa and the ground/power line **115**G/P may also have the structures of one or three or more layers of via pads **118**S and the first horizontal lines **117**G/P surrounding the via pads **118**S.

[0080] FIGS. **10**A and **10**B are a TDR graph and an insertion loss graph of a package substrate of a first comparative example and the package substrate of FIG. **9**, wherein the dotted line represents the package substrate Com.1 of the first comparative example, and the solid line represents the package substrate **100***a* of FIG. **9**. In FIG. **10**A, the x axis represents time and the unit thereof is nano-seconds (ns), and the y axis represents impedance and the unit thereof is ohm (Ω). In FIG.

10B, the x axis represents frequency and the unit thereof is gigahertz (GHz), and the y axis represents insertion loss and the unit thereof is dB.

[0081] Referring to FIG. **10**A, Ball, Trace, and Bump displayed at the top of the graph may respectively represent the lower substrate pad SPb, a trace line of the second line **135**, and a bump pad (or upper substrate pad). As can be seen from the graph of FIG. **10**A, it may be seen that the impedance is greatly reduced in the portion of the lower substrate pad SPb. In particular, in the case of the package substrate Com.1 of the first comparative example, the impedance drops to around 20Ω at the lower substrate pad SPb, but in the case of the package substrate **100***a* of the embodiment, the impedance drops only to 30Ω at the lower substrate pad SPb, and the impedance greatly increases to 65Ω immediately after the lower substrate pad SPb. Because the approximate average of an undershoot and an overshoot is about 50Ω, which becomes almost the same as the impedance of the trace line portion, and thus it may be seen that impedance discontinuity is greatly improved.

[0082] Referring to FIG. **10**B, it may be seen that the insertion loss of the package substrate **100***a* of the embodiment is improved compared to the package substrate Com. 1 of the first comparative example due to the improvement in impedance discontinuity. In particular, at a third frequency (3.2 GHZ), the insertion loss of the package substrate Com.1 of the first comparative example is-1.111 dB, and the insertion loss of the package substrate **100***a* of the embodiment is −0.813 dB, which may be confirmed that the insertion loss of the package substrate **100***a* of the embodiment has improved by about 27%.

[0083] In addition, in the case of eye-opening characteristics, at a 6.4 Gbps signal, an eye-opening value of the package substrate Com.1 of the first comparative example may be calculated to be about 49%, and an eye-opening value of the package substrate **100***a* of the embodiment may be calculated to about 62%.

[0084] Accordingly, it may be confirmed that the eye-opening characteristics of the package substrate **100***a* of the embodiment are improved by about 13% compared to the package substrate Com.1 of the first comparative example.

[0085] FIGS. **11**A to **12** are cross-sectional views of semiconductor packages according to embodiments. Description is made with reference to FIGS. **1**A and **1**B together, and descriptions already given with reference to FIGS. **1**A to **10**B are briefly given or omitted.

[0086] Referring to FIG. **11**A, a semiconductor package **1000** of an embodiment may include the package substrate **100**, the external connection terminal **150**, a semiconductor chip **300**, an adhesive layer **400**, and a sealant **500**.

[0087] The package substrate **100** may be the package substrate **100** of FIG. **1**A or the package substrate **100***a* of FIG. **9**. The package substrate **100** is as described in the description with reference to FIGS. **1**A to **2**C. In the semiconductor package **1000** of the embodiment, the package substrate **100** may include the first signal lines **115**S, **115**S′, and **115**S″ in various forms, as shown in FIGS. **3**A to **4**B. The first signal lines **115**S, **115**S′, and **115**S″ may be arranged in the form of an inductor within the first body **111** of the first line layer **110**. In FIG. **11**A, the package substrate **100** is simply shown in the form of a flat plate, and particular components are omitted. Hereinafter, in the semiconductor packages **1000***a*, **1000***b*, **1000***d* and semiconductor devices **10000** and **10000***a* of other embodiments, the package substrate **100** is also shown in the form of a flat plate.

[0088] The external connection terminal **150** may be arranged on the lower surface of the package substrate **100**. The external connection terminal **150** may be electrically connected to the first line **115** of the first line layer **110** through the lower substrate pad Spb. The external connection terminal **150** may be formed as a solder ball. However, according to embodiments, the external connection terminal **150** may also have a structure including a pillar and a solder. The semiconductor package **1000** of the embodiment may be mounted on a main board, a mother board, a system board, or the like of an external device through the external connection terminal **150**.

[0089] The semiconductor chip **300** may be stacked on the package substrate **100**. In the

semiconductor package **1000** of the embodiment, although one semiconductor chip **300** is stacked on the package substrate **100**, the number of semiconductor chips **300** stacked on the package substrate **100** is not limited to one. For example, a plurality of semiconductor chips **300** may be stacked on the package substrate **100**. A structure in which a plurality of semiconductor chips **300** are stacked on the package substrate **100** is described in more detail with reference to FIG. **11**B.

[0090] The semiconductor chip **300** may include a chip substrate **301**, an element layer **310**, and a bump **320**. The chip substrate **301** may be based on a semiconductor material such as a silicon wafer or the like. The element layer **310** may be arranged on the lower surface of the chip substrate **301** and include various types of elements. For example, the element layer **310** may include various active and/or passive elements, for example, field effect transistors (FET) such as planar FETs or FinFETs, memory elements such as flash memory, dynamic random-access memory (DRAM), static random-access memory (SRAM), electrically erasable programmable read-only memory (EEPROM), phase-change random-access memory (PRAM), magnetoresistive random access memory (MRAM), ferroelectric random-access memory (FeRAM), resistive random-access memory (RRAM), or the like, logic elements such as AND, OR, NOT, or the like, system large scale integration (LSI), complementary metal-oxide semiconductor (CMOS) imaging sensors (CIS), and micro-electro-mechanical systems (MEMS). For example, in the semiconductor package **1000** of the embodiment, the semiconductor chip **300** may be a DRAM chip including DRAM elements in the element layer **310**. Accordingly, the semiconductor package **1000** of the embodiment may be used in a high bandwidth memory (HBM) product, an electro-date processing (EDP) product, or the like. In the semiconductor package **1000** of the embodiment, the type of the semiconductor chip **300** is not limited to a DRAM chip.

[0091] The bump **320** may be arranged on the lower surface of the element layer **310** and may be electrically connected to the element layer **310** through a line. The bump **320** may include, for example, a pillar and a solder. According to embodiments, the bump **320** may also include only a solder without including a pillar.

[0092] According to embodiments, the semiconductor chip **300** may be mounted on the package substrate **100** through wire bonding. In this case, the bump **320** may be omitted. In addition, the semiconductor chip **300** may be mounted on the package substrate **100** in a structure in which the element layer **310** faces upward, and the semiconductor chip **300** may be electrically connected to the package substrate **100** through a wire.

[0093] The semiconductor chip **300** may be mounted on the package substrate **100** through the bump **320** and the adhesive layer **400**. The adhesive layer **400** may be formed of an underfill or an adhesive film such as a non-conductive film (NCF). According to embodiments, the semiconductor package **1000** may be manufactured through a molded underfill (MUF) process, and in this case, the adhesive layer **400** may be omitted.

[0094] The sealant **500** may cover a portion of the upper surface of the package substrate **100**, the upper surface of the semiconductor chip **300**, the side surface of the semiconductor chip **300**, and the side surface of the adhesive layer **400**. As shown in FIG. **11**A, the sealant **500** may have a certain thickness and cover the upper surface of the semiconductor chip **300**. However, according to embodiments, the sealant **500** may also not cover the upper surface of the semiconductor chip **300** so that the upper surface of the semiconductor chip **300** is exposed to the outside from the sealant **500**. The sealant **500** may include, for example, an epoxy mold compound (EMC). However, the material of the sealant **500** is not limited to an EMC.

[0095] Referring to FIG. **11**B, the semiconductor package **1000***a* of the embodiment may be different from the semiconductor package **1000** of FIG. **11**A in that four semiconductor chips (that is, first to fourth semiconductor chips **300-1**, **300-2**, **300-3**, and **300-4**) are stacked on the package substrate **100**. In the semiconductor package **1000***a* of the embodiment, although four semiconductor chips (that is, first to fourth semiconductor chips **300-1**, **300-2**, **300-3**, and **300-4**) are stacked on the package substrate **100**, the number of semiconductor chips stacked on the

package substrate **100** is not limited to four. For example, two, three, or five or more semiconductor chips may also be stacked on the package substrate **100**.
[0096] Each of the first to fourth semiconductor chips **300-1** to **300-4** is, for example, a memory chip, and may be similar to the semiconductor chip **300** of the semiconductor package **1000** of FIG. **11**A. However, as shown in FIG. **11**B, each of the first to third semiconductor chips **300-1** to **300-3** may further include a through silicon via (TSV) **330** penetrating the chip substrate **301**. The fourth semiconductor **300-4** at the uppermost end may not include the TSV **330**. The first to fourth semiconductor chips **300-1** to **300-4** may be electrically connected to the package substrate **100** through the TSVs **330** and the bump **320**.
[0097] The first semiconductor chip **300-1** may be stacked on the package substrate **100** through the bump **320** and the adhesive layer **400**. In addition, each of the second to fourth semiconductor chips **300-2** to **300-4** may be stacked on a corresponding lower semiconductor chip through the bump **320** and the adhesive layer **400**. The adhesive layer **400** may have a structure that slightly protrudes outward from a corresponding semiconductor chip.
[0098] According to embodiments, the first to fourth semiconductor chips **300-1** to **300-4** may be mounted on the package substrate **100** through wire bonding. In this case, the first to third semiconductor chips **300-1** to **300-3** may not include TSVs **330**. In addition, the first to fourth semiconductor chips **300-1** to **300-4** may be stacked on the package substrate **100** or a corresponding lower semiconductor chip through adhesive layers so that the element layer **310** faces upward. In addition, for wire bonding, the first to fourth semiconductor chips **300-1** to **300-4** may be stacked on the package substrate **100** in a zigzag structure or a staircase structure, and may be electrically connected to the package substrate **100** through wires.
[0099] The sealant **500** may cover a portion of the upper surface of the package substrate **100**, the side surfaces of the first to fourth semiconductor chips **300-1** to **300-4**, and the side surface of the adhesive layer **400**. As shown in FIG. **11**B, the upper surface of the fourth semiconductor chip **300-4** at the uppermost end may not be covered by the sealant **500**. However, according to embodiments, the upper surface of the fourth semiconductor chip **300-4** may also be covered by the sealant **500**.
[0100] Referring to FIG. **12**, the semiconductor package **1000***b* of an embodiment may include the package substrate **100**, the external connection terminal **150**, a lower semiconductor chip **300***d*, upper semiconductor chips **300***u***1** and **300***u***2**, first and second sealants **500***a* and **500***b*, a through post **530**, a redistribution substrate **550**, and a passive element **670** (e.g., resistor, capacitor, inductor). The package substrate **100** may be the package substrate **100** of FIG. **1**A or the package substrate **100***a* of FIG. **9**. The external connection terminal **150** may be arranged on the lower surface of the package substrate **100**.
[0101] For reference, a structure in which external connection terminals are widely arranged beyond the lower surface of a corresponding semiconductor chip is referred to as a fan-out (FO) structure. In addition, a semiconductor package including a package substrate in an FO structure based on a wafer is referred to as an FO wafer level package (FOWLP), and a semiconductor package including a package substrate in an FO structure based on a panel is referred to as an FO panel level package (FOPLP). In the semiconductor package **1000***b* of the embodiment, the package substrate **100** may be based on a panel. Accordingly, the semiconductor package **1000***b* of the embodiment may correspond to an FOPLP.
[0102] The lower semiconductor chip **300***d* may be mounted on the package substrate **100** through a bump **320***d* and an adhesive layer **400***d* and may be sealed by the first sealant **500***a*. The lower semiconductor chip **300***d* may include a logic semiconductor chip and/or a memory semiconductor chip. For example, the logic semiconductor chip may be an application processor (AP), a micro-processor, a central processing unit (CPU), a controller, an application specific integrated circuit (ASIC), or the like. In addition, the memory semiconductor chip may be, for example, voltage memory such as DRAM, SRAM, or the like, or non-volatile memory such as flash memory or the

like.
[0103] The through post **530** may be arranged within the first sealant **500***a*. The through post **530** may be formed by forming the first sealant **500***a*, then forming a through hole penetrating the first sealant **500***a*, and then filling the through hole with a conductive material. However, in another embodiment, the through post **530** may also be first formed through plating or the like, and then the first sealant **500***a* may also be formed to surround the through post **530**.
[0104] The redistribution substrate **550** may be arranged on the lower semiconductor chip **300***d* and the first sealant **500***a*. The redistribution substrate **550** may include a redistribution line therein. The redistribution line of the redistribution substrate **550** may be connected to the through post **530** therebelow.
[0105] The upper semiconductor chips **300***u***1** and **300***u***2** and the passive element **670** may be mounted on the redistribution substrate **550** and sealed by the second sealant **500***b*. The upper semiconductor chips **300***u***1** and **300***u***2** may include a first upper semiconductor chip **300***u***1** and a second upper semiconductor chip **300***u***2**. For example, the first upper semiconductor chip **300***u***1** and the second upper semiconductor chip **300***u***2** may be different types of memory chips. The upper semiconductor chips **300***u***1** and **300***u***2** may be stacked on the redistribution substrate **550** through a bump **320***u* and an adhesive layer **400***u*. The upper semiconductor chips **300***u***1** and **300***u***2** and the passive element **670** may be electrically connected to the redistribution line of the redistribution substrate **550**.
[0106] FIGS. **13**A and **13**B are a perspective view and a cross-sectional view of a semiconductor device according to an embodiment. Description is made with reference to FIGS. **1**A and **1**B together, and descriptions already given with reference to FIGS. **1**A to **12** are briefly given or omitted.
[0107] Referring to FIGS. **13**A and **13**B, a semiconductor device **10000** of an embodiment may include the package substrate **100**, the external connection terminal **150**, a semiconductor package **1000***d*, an interposer **600**, and a logic chip **700**. The package substrate **100** may be the package substrate **100** of FIG. **1**A or the package substrate **100***a* of FIG. **9**. The external connection terminal **150** may be arranged on the lower surface of the package substrate **100**.
[0108] The semiconductor package **1000***d* may be the semiconductor package **1000***a* of FIG. **11**B. However, in the semiconductor device **10000** of the embodiment, the semiconductor package **1000***d* is not limited to the semiconductor package **1000***a* of FIG. **11**B. For example, the semiconductor package **1000***d* may also be the semiconductor package **1000** of FIG. **11**A or the semiconductor package **1000***b* of FIG. **12**. In addition, the semiconductor package **1000***d* may be an HBM package. When the semiconductor package **1000***d* is an HBM package, the structure is similar to the semiconductor package **1000***a* of FIG. **11**B, but a buffer chip may be placed at the bottom instead of a package substrate. In the semiconductor device **10000** of the embodiment, four semiconductor packages **1000***d* are mounted on the interposer **600**, but the number of semiconductor packages **1000***d* is not limited to four. For example, one to three or five or more semiconductor packages **1000***d* may be mounted on the interposer **600**.
[0109] The interposer **600** may include an interposer substrate **601**, an upper protective layer **603**, an upper pad **605**, a line layer **610**, a bump **620**, and a through electrode **630**. The semiconductor package **1000***d* and the logic chip **700** may be mounted on the package substrate **100** by using the interposer **600** as a medium. The interposer **600** may connect the semiconductor package **1000***d* and the logic chip **700** to each other, and may also connect the semiconductor package **1000***d* and the logic chip **700** to the package substrate **100**.
[0110] For example, the interposer substrate **601** may be formed of any one of silicon, an organic material, plastic, and a glass substrate. However, the material of the interposer substrate **601** is not limited to the above materials. When the interposer substrate **601** is a silicon substrate, the interposer **600** may be referred to as a silicon interposer. In addition, when the interposer substrate **601** is an organic material substrate, the interposer **600** may be referred to as a panel interposer.

[0111] The upper protective layer **603** may be arranged on the upper surface of the interposer substrate **601**, and the upper pad **605** may be arranged on the upper protective layer **603**. The upper pad **605** may be connected to the through electrode **630**. The semiconductor package **1000***d* and the logic chip **700** may be stacked on the interposer **600** through bumps **320***c* arranged on the upper pad **605**. The line layer **610** may be arranged on the lower surface of the interposer substrate **601** and have a single-layered structure or a multi-layered structure.
[0112] The through electrode **630** may penetrate the interposer substrate **601** and extend. In addition, the through electrode **630** may extend to the inside of the line layer **610** to be electrically connected to lines of the line layer **610**. When the interposer substrate **601** includes silicon, the through electrode **630** may be referred to as a TSV. According to embodiments, the interposer **600** may also include only a line layer therein, and a through electrode may be not included.
[0113] In the semiconductor device **10000** of the embodiment, the interposer **600** may be used to convert or transmit signals between the semiconductor package **1000***d* and the logic chip **700**, between the package substrate **100** and the semiconductor package **1000***d*, or between the package substrate **100** and the logic chip **700**. Accordingly, the interposer **600** may not include elements such as active elements or passive elements. In the interposer **600**, although the line layer **610** is arranged on the lower portion of the through electrode **630**, but according to embodiments, the line layer **610** may also be arranged on the upper portion of the through electrode **630**. For example, the positional relationship between the line layer **610** and the through electrode **630** may be relative.
[0114] The bump **620** may be arranged on the lower surface of the interposer **600** and may be electrically connected to a line of the line layer **610**. The interposer **600** may be mounted on the package substrate **100** through the bump **620**. The bump **620** may be connected to the upper pad **605** through the lines of the line layer **610** and the through electrode **630**.
[0115] The logic chip **700** may be a processor chip. For example, the logic chip **700** may be a GPU/CPU/SOC chip. Depending on the type of elements included in the logic chip **700**, the semiconductor device **10000** may be distinguished into a server-type semiconductor device or a mobile-type semiconductor device, or the like.
[0116] Although not illustrated in the drawing, the semiconductor device **10000** may include an internal sealant that seals the semiconductor package **1000***d* and the logic chip **700** on the interposer **600**. In addition, the semiconductor device **10000** may include an external sealant that seals the interposer **600** and the internal sealant on the package substrate **100**. According to embodiments, the external sealant and the internal sealant may not be distinguished by being formed together. In addition, according to embodiments, the internal sealant may cover only the upper surface of the logic chip **700** but may not cover the upper surface of the semiconductor package **1000***d*.
[0117] For example, the structure of the semiconductor device **10000** as in the embodiment is referred to as a 2.5 dimensional (D) package structure, and the 2.5D package structure may be a relative concept to a 3D package structure without an interposer. Both the 2.5D package structure and the 3D package structure may be included in a system-in-package (SIP) structure. The semiconductor device **10000** of the embodiment may also be a type of semiconductor package. However, because the semiconductor device **10000** may include the semiconductor package **1000***d* corresponding to the semiconductor packages **1000** and **1000***a* to **1000***b* of FIGS. **11**A to **12**, it is called a semiconductor device to be terminologically distinguished from the semiconductor package **1000***d*. Hereinafter, the same concept may also be applied to the semiconductor device **10000***a* of FIG. **14**.
[0118] FIG. **14** is a cross-sectional view of a semiconductor device according to an embodiment. Description is made with reference to FIGS. **1**A and **1**B together, and descriptions already given with reference to FIGS. **1**A to **12** are briefly given or omitted.
[0119] Referring to FIG. **14**, the semiconductor device **10000***a* of the embodiment may include the package substrate **100**, the external connection terminal **150**, first and second memory chips **300***a*

and **300***b*, a logic chip **700***a*, an internal sealant **500***c*, and an external sealant **500***d*. The package substrate **100** may be the package substrate **100** of FIG. **1**A or the package substrate **100***a* of FIG. **9**. The external connection terminal **150** may be arranged on the lower surface of the package substrate **100**.

[0120] Two memory chips including the first and second memory chips **300***a* and **300***b* may be mounted on the logic chip **700***a*. The two memory chips including the first and second memory chips **300***a* and **300***b* may also be the same memory chips. For example, the two memory chips including the first and second memory chips **300***a* and **300***b* may all be SRAM chips. However, according to embodiments, the two memory chips including the first and second memory chips **300***a* and **300***b* may be different memory chips. For example, the first memory chip **300***a* may be an SRAM chip, and the second memory chip **300***b* may be a DRAM chip.

[0121] The number of memory chips stacked on the logic chip **700***a* is not limited to two. For example, one or three or more memory chips may be stacked on the logic chip **700***a*. In addition, the type of memory chips is not limited to an SRAM chip or a DRAM chip. For example, various types of memory chips described above may be included in the semiconductor device **10000***a* of the embodiment. Furthermore, a memory package may also be mounted on the logic chip **700***a* instead of the two memory chips including the first and second memory chips **300***a* and **300***b*. The memory package may include at least two memory chips. In addition, three or more memory packages may also be mounted on the logic chip **700***a*.

[0122] The logic chip **700***a* may be mounted on the package substrate **100**. The logic chip **700***a* may include various types of processor chips, such as GPU/CPU/SOC chips or the like. The internal sealant **500***c* may seal the first and second memory chips **300***a* and **300***b* on the logic chip **700***a*. In addition, the external sealant **500***d* may seal the logic chip **700***a* on the package substrate **100** and the internal sealant **500***c*. Because the logic chip **700***a* is stacked on the package substrate **100**, and the first and second memory chips **300***a* and **300***b* are stacked on the logic chip **700***a*, the semiconductor device **10000***a* of the embodiment may correspond to a 3D package structure.

[0123] One or more of the elements disclosed above may include or be implemented in processing circuitry such as hardware including logic circuits; a hardware/software combination such as a processor executing software; or a combination thereof. For example, the processing circuitry more specifically may include, but is not limited to, a central processing unit (CPU), an arithmetic logic unit (ALU), a digital signal processor, a microcomputer, a field programmable gate array (FPGA), a System-on-Chip (SoC), a programmable logic unit, a microprocessor, application-specific integrated circuit (ASIC), etc.

[0124] While inventive concepts have been particularly shown and described with reference to embodiments thereof, it will be understood that various changes in form and details may be made therein without departing from the spirit and scope of the following claims.

Claims

1. A package substrate comprising: a core layer; a first line layer on a lower surface of the core layer and including multiple layers of first lines; and a second line layer on an upper surface of the core layer and including multiple layers of second lines, wherein the core layer includes a core body and a core via, the core via penetrates the core body and extends in a vertical direction, a first signal line of the first lines is connected to a second signal line of the second lines through the core via, and the first signal line is arranged in a form of an inductor in the first line layer.

2. The package substrate of claim 1, wherein the first signal line has a spring form extending in the vertical direction while rotating clockwise or counterclockwise in the first line layer.

3. The package substrate of claim 2, wherein the spring form has a circular form, an oval form, or a polygonal form when viewed on a plane perpendicular to the vertical direction.

4. The package substrate of claim 1, wherein the first signal line comprises a horizontal line, a

vertical via, and adjacent horizontal lines in the vertical direction, the horizontal line extends on a plane perpendicular to the vertical direction, and the vertical via connects the adjacent horizontal lines in the vertical direction to each other.

5. The package substrate of claim 4, wherein the horizontal line configures the inductor to have a structure that rotates clockwise or counterclockwise while the horizontal line is connected to one of the adjacent horizontal lines in the vertical direction through the vertical via.

6. The package substrate of claim 4, wherein the vertical via is part of a first vertical via group arranged at a first position on the plane or a second vertical via group arranged at a second position spaced apart from the first position on the plane, the horizontal line is part of a first horizontal line group at a first side of the inductor or a second horizontal line group at a second side of the inductor.

7. (canceled)

8. (canceled)

9. The package substrate of claim 1, further comprising: a lower substrate pad on a lower surface of the package substrate; and an external connection terminal on a lower surface of the lower substrate pad, wherein a portion of the lower substrate pad overlaps a ground line or a power line of the first lines in the vertical direction.

10. The package substrate of claim 1, further comprising: a lower substrate pad on a lower surface of the package substrate; and an external connection terminal on a lower surface of the lower substrate pad, wherein the core layer includes a core pad overlapping the first line layer, and a dielectric void filled only with a dielectric material is not formed between the lower substrate pad and the first line layer overlapping a core pad of the core via.

11. A package substrate comprising: a body layer having an upper surface and a lower surface; and multiple layers of lines in the body layer, wherein the lines comprise a signal line configured to transmit a signal, the signal line comprises a horizontal line and a vertical via, the horizontal line extends in the body layer in a horizontal direction parallel to the upper surface of the body layer, the vertical via is configured to connect adjacent horizontal lines in a vertical direction to each other in the body layer, the vertical direction is perpendicular to the horizontal direction, and the horizontal line and the vertical via configure an inductor in the body layer.

12. The package substrate of claim 11, wherein the body layer comprises a core body at a center of the body layer in the vertical direction, a first body on a lower portion of the core body, and a second body on an upper portion of the core body, the lines comprise first lines in the first body and second lines in the second body, the signal line comprises a first signal line among the first lines and a second signal line among the second lines, and the first signal line is connected to the second signal line through a core via penetrating the core body and forms the inductor in the first body.

13. The package substrate of claim 12, wherein the first signal line has a spring form extending in the vertical direction while rotating clockwise or counterclockwise in the first body.

14. The package substrate of claim 13, wherein the first signal line comprises a first horizontal line among horizontal lines in the first body and a first vertical via among vertical vias in the first body, the first vertical via connects adjacent first horizontal lines in the vertical direction to each other, and the first horizontal line configures the inductor to have a structure that rotates clockwise or counterclockwise while being connected to a first horizontal line of an other layer through the first vertical via.

15. The package substrate of claim 12, further comprising: a lower substrate pad is on a lower surface of the body layer; and an external connection terminal on a lower surface of the lower substrate pad, wherein a portion of the lower substrate pad overlaps a ground line or a power line of the first lines in the vertical direction.

16. The package substrate of claim 11, wherein the horizontal line comprises a first horizontal line in the body layer as a part of the inductor and a second horizontal line at an uppermost portion of the body layer, and the vertical via is configured to connect adjacent first horizontal lines in the

vertical direction to each other, connect the first horizontal line at an uppermost portion to the second horizontal line, or connect the first horizontal line at a lowermost portion to a lower substrate pad on the lower surface of the body layer.

17. The package substrate of claim 16, wherein the first horizontal line configures the inductor to have a structure that rotates clockwise or counterclockwise while being connected to an other first horizontal line of an other layer through the vertical via.

18. A semiconductor package comprising: a package substrate; at least one semiconductor device mounted on the package substrate; and a sealant configured to seal the at least one semiconductor device on the package substrate, wherein the package substrate comprises a body layer having an upper surface and a lower surface and multiple layers of lines in the body layer, the lines comprise a signal line configured to transmit a signal, the signal line comprises a horizontal line and a vertical via, the horizontal line extending in the body layer in a horizontal direction parallel to the upper surface of the body layer, and the vertical via being configured to connect adjacent horizontal lines in a vertical direction to each other in the body layer, and the horizontal line and the vertical via configure an inductor in the body layer.

19. The semiconductor package of claim 18, wherein the body layer comprises a core body at a center of the body layer in the vertical direction, a first body on a lower portion of the core body, and a second body on an upper portion of the core body, the lines comprise first lines in the first body and second lines in the second body, the signal line comprises a first signal line among the first lines and a second signal line among the second lines, and the first signal line is connected to the second signal line through a core via penetrating the core body and forms the inductor in the first body.

20. The semiconductor package of claim 19, wherein the first signal line has a spring form extending in the vertical direction while rotating clockwise or counterclockwise in the first body.

21. The semiconductor package of claim 19, wherein the package substrate further includes a lower substrate pad on the lower surface of the body layer and an external connection terminal on a lower surface of the lower substrate pad, and a portion of the lower substrate pad overlaps a ground line or a power line of the first lines in the vertical direction.

22. The semiconductor package of claim 18, wherein the horizontal line comprises a first horizontal line in the body layer as a part of the inductor and a second horizontal line at an uppermost portion of the body layer, and the vertical via is configured to connect adjacent first horizontal lines in the vertical direction to each other, connect the first horizontal line at an uppermost portion to the second horizontal line, or connect the first horizontal line at a lowermost portion to a lower substrate pad arranged on the lower surface of the body layer.

23.-**25**. (canceled)